



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:)
Huang et al.) Examiner: Lee, C.
Application No.: 10/063,055) Art Unit: 2627
Filed: March 15, 2002)
For: Document Surface Micro-Adjust)
Mechanism)
)

COMMISSIONER FOR PATENTS
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AMENDMENT UNDER 37 CFR 1.114

Dear Sir:

A Request for Continued Examination (RCE) under 37 CFR 1.114 is made regarding the above-referenced patent application. Assignee respectfully requests that the Examiner enter the following amendment, which includes an amendment to the claims, and consider the following remarks.

Amendments begin on page 2.

Remarks begin on page 6.